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THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Inventors: Shinya ABE

ATTN: ISSUE FEE BRANCH

Application No.: 09/711,905 ✓

Allowed: December 1, 2004

Art Unit: 2653

Filed: November 15, 2000

Examiner: K. Chu

For: FOCUSING METHOD, METHOD OF DETECTING FOCAL POINT DEVIATION,
METHOD OF FORMING MASTER OF DATA STORAGE MEDIUM, FOCUSING
CONTROL UNIT, UNIT FOR DETECTING FOCAL POINT DEVIATION, AND
UNIT FOR FORMING MASTER OF DATA STORAGE MEDIUM

REQUEST FOR CONSIDERATION OF
INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner of Patents
Washington, DC 20231

Dear Sir:

With respect to the Information Disclosure Statement filed July 25,
2003, Applicants respectfully request that the Examiner initial and
return a copy of the previously supplied Form PTO-1449 indicating
consideration of the cited references. For the convenience of the
Examiner, a copy of that Form PTO-1449 is attached, as well as a copy of
the IDS, references and PTO date-stamped filing receipt.

Respectfully submitted,

James E. Ledbetter
Registration No. 28,732

Date: December 10, 2004

JEL/ejw

Attorney Docket No. L8462.00102

STEVENS, DAVIS, MILLER & MOSHER, L.L.P.
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THE PATENT AND TRADEMARK OFFICE OFFICIAL FILING DATE STAMP HEREON IS
ACKNOWLEDGMENT OF FILING:

<input type="checkbox"/> Amendment	<input type="checkbox"/> New Patent Application
<input type="checkbox"/> Response to Restriction Requirement	<input type="checkbox"/> Pages of Specification
<input type="checkbox"/> Supplemental Amendment	<input type="checkbox"/> Claims
<input type="checkbox"/> Election Requirement	<input type="checkbox"/> Declaration/Power of Attorney
<input type="checkbox"/> Claim for Priority w/ Certified Priority Document	<input type="checkbox"/> Abstract of the Disclosure
<input type="checkbox"/> Petition for Month Extension of Time	<input type="checkbox"/> Pages Formal/Informal Drawings
<input type="checkbox"/> Request for Consideration	<input type="checkbox"/> Assignment Document w/PTO-1595
<input type="checkbox"/> Letter to Official Draftsman	<input type="checkbox"/> Small Entity Declaration
<input type="checkbox"/> with shts. of formal drwgs.	<input checked="" type="checkbox"/> Information Disclosure Statement
<input type="checkbox"/> Issue Fee Transmittal (in dup.)	w/PTO-1449, Japanese Office Action
<input type="checkbox"/> Change of Address and Associate	dtd. 06/15/03, 5 foreign pat. docs., 1
<input type="checkbox"/> Power of Attorney	English Abstract, 4 English transl.

APPLICANT(S): Shinya ABE

TITLE: FOCUSING METHOD, METHOD OF DETECTING FOCAL POINT DEVIATION,
METHOD OF FORMING MASTER OF DATA STORAGE MEDIUM, FOCUSING
CONTROL UNIT, UNIT FOR DETECTING FOCAL POINT DEVIATION, AND
UNIT FOR FORMING MASTER OF DATA STORAGE MEDIUM

DATE: November 15, 2000

DOCKET NO.: L8462.00102

APPLN. NO.: 09/711,905

CLIENT NAME: MIYAI PATENT OFFICE

CLIENT NO.: 8462

CLIENT REF. #: PM0009-US

ASSIGNEE: MATSUSHITA ELECTRIC INDUSTRIAL CO., LTD.

Date Filed: July 25, 2003

Old Due Date:

New Due Date:

Attorney Initials: _____




IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Inventor(s): Shinya ABE Art Unit: 2612

Application No.: 09/711,905

Filed: November 15, 2000

For:  FOCUSING METHOD, METHOD OF DETECTING FOCAL POINT
DEVIATION, METHOD OF FORMING MASTER OF DATA STORAGE
MEDIUM, FOCUSING CONTROL UNIT, UNIT FOR DETECTING FOCAL
POINT DEVIATION, AND UNIT FOR FORMING MASTER OF DATA
STORAGE MEDIUM

INFORMATION DISCLOSURE STATEMENT

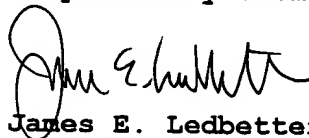
Assistant Commissioner of Patents
Washington, DC 20231

Dear Sir:

Pursuant to Rules 56 and 99, Applicants hereby call the attention of the Patent Office to the art listed on the attached Form PTO 1449. All of these references were cited in a Japanese Office Action dated June 15, 2003.

Applicants present this art so that the Patent Office may, in the first instance, determine any relevancy thereof to the presently claimed invention, see Beckman Instruments, Inc. v. Chemtronics, Inc., 439 F.2d 1369, 1380, 165 USPQ 355, 364 (5th Cir. 1970). Also see Patent Office Rules 104 and 106. Applicants respectfully request that this art be expressly considered during the prosecution of this application and made of record herein and appear among the "References Cited" on any patent to issue herefrom.

Respectfully submitted,



James E. Ledbetter
Registration No. 28,732

Date: July 25, 2003

JEL/apg

ATTORNEY DOCKET NO. 8462.00102
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ATTY. DOCKET NO.

L8462.00102

SERIAL NO.

09/711,905

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use several sheets if necessary)

APPLICANT

Shinya ABE

FILING DATE

November 15, 2000

GROUP

2612

U.S. PATENT DOCUMENTS

[illegible]

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER								DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
		YES	NO												
		6	3	2	9	8	8	3	9	12/1998	JP			Abstract	
		0	9	2	4	5	3	8	3	09/1997	JP			X	
		0	8	0	7	7	6	1	7	03/1996	JP			X	
		0	9	0	5	4	9	8	9	02/1997	JP			X	
		0	9	0	0	7	1	9	6	01/1997	JP			X	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

Japanese Office Action dated June 15, 2003.

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation is considered, draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.